In re Application of:

Docket No. 03560.002998.1.

YUKIKO IWASAKI, ET AL.

Application No.: 10/658,294

Examiner: Asok K. Sarkar

Filed: September 10, 2003

Group Art Unit: 2829

For: METHOD FOR MANUFACTURING A

SEMICONDUCTOR FILM

Date: October 14, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 13	MINUS	** 20	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	* 1	MINUS	***	= 0	x \$44 \$88	\$0.00
Fee for Multiple Dependent claims \$150°/\$300					\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00	

If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space. If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

	Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Peter G. Thurlow

Registratio

Attorney for Applicants Registration No.: 47,138

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
YUKIKO IWASAKI, ET AL.	Examiner: Asok K. Sarkar
Application No.: 10/658,294	: Group Art Unit: 2829 )
Filed: September 10, 2003	· ) :
For: METHOD FOR MANUFACTURING A SEMICONDUCTOR FILM	) : October 14, 2004
Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

## **AMENDMENT**

Sir:

In response to the Office Action dated July 14, 2004, please amend the above-identified application as follows. The specification changes begin at page 2, the claim amendments are reflected in the listing that begins at page 3, and the Remarks begin at page 7.

I hereby certi	fy that this correspondence is being deposited with the			
United States Postal Service as first-class mail in an envelope addressed				
to: Commissi	oner for Patents, P.O. Box 1450, Alexandria, VA 22313			
1450 on	October 14, 2004			
	(Date of Deposit)			
	Peter G. Thurlow (Reg. No. 47,138)			

(Name of Attorney for Applicants)

ignature I

Date of Signature